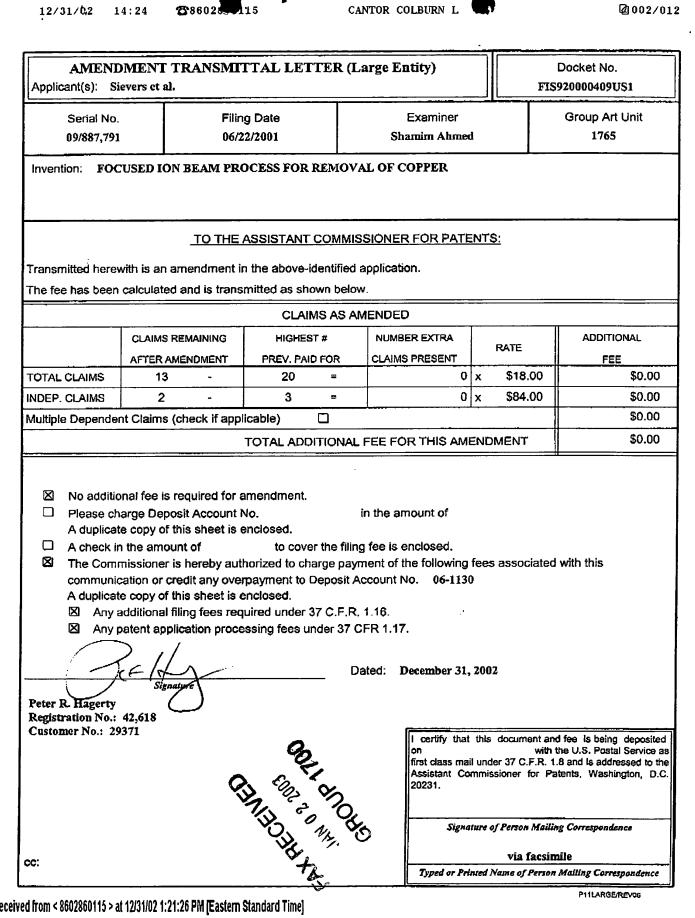
CERTIFICATE OF Applicant(s): Sievers et a	TRANSMISSION BY FACS	SIMILE (37 CFR 1.8)	Docket No. FIS920000409US1	
Serial No. 09/887,791	Filing Date 06/22/2001	Examiner Shamim Ahmed	Group Art Unit 1765	
Invention: FOCUSED IO	ON BEAM PROCESS FOR REM	IOVAL OF COPPER		
I hereby certify that this				
on December 3		and Trademark Office (Fax. N	0. 703-672-9310	
(Date)				
Patricia A. Hart (Typed o) Prihied Name of Person Signing Certificate) (Signature)				
	Note: Fach paper must be	ve its own certificate of mailing.		
	Note: Each paper hust he			
·		Q	Oct NORSONE MAN	



Ø003/012

#5/A 401 3/17/03

FIS920000409US1 I26-0013

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Sievers et al.)
Serial No.:	09/887,791) Group Art Unit: 1765
Filed:	June 22, 2001) Examiner: Ahmed, Shamim
For:	FOCUSED ION BEAM PROCESS FOR REMOVAL OF COPPER))

AMENDMENT A

Via Facsimile to: 703-872-9310 Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

This amendment is submitted in response to the Office Action dated December 12, 2002. Please amend the Application as follows:

FAX PECENED
JAN 0.2 2003
GROUP 1700